Notice of Allowability 10/720,092	Notice of Allowability	Application No.	Applicant(s)	
Examiner		10/720 092	OKUMURA ET AI	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address-All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed, a Notice of Allowance (PTOL-85) or other appropriate communication with bemild induce ourse. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initia of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. 1. □ This communication is responsive to				
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Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/08), Paper No./Mail Date 7. ☐ Examiner's Amendment/Comment Paper No./Mail Date 122204 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT ROTH OF the Office or upon petition by the applicant. See 37 CFR 1.31 1. This communication is responsive to 2. The allowed claim(s) is/are 1-11. 3. Acknowledgment is made of a claim for foreign priority uses a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have a compared to priority documents have a claim for foreign priority documents have a claim	ears on the cover sheet will a cover sheet will be cover sheet will be cover sheet will be cover appropriate communities. This application is a cover and MPEP 1308. Inder 35 U.S.C. § 119(a)-(d) be been received. The sheet received in Application becoments have been received becoments have been received. The sheet sheet attached EXIVES reason(s) why the oath of the submitted. Son's Patent Drawing Review of Sheet attached EXIVES reason(s) why the oath of the submitted. Son's Patent Drawing Review of Sheet attached EXIVES at the submitted of the header according to 37 CF osit of BIOLOGICAL MATERIAL CONTRACT.	th the correspondence address- in this application. If not included unication will be mailed in due course. To subject to withdrawal from issue at the in or (f). on No d in this national stage application from a reply complying with the requirement AMINER'S AMENDMENT or NOTICE Or or declaration is deficient. or (PTO-948) attached or in the Office action of the drawings in the front (not the back) of the drawings in the submitted. Note the	nitiative the ts
Kin-Chan Chen Primary Examiner	 Notice of References Cited (PTO-892) Notice of Draftperson's Patent Drawing Review (PTO-948) Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date 122204 Examiner's Comment Regarding Requirement for Deposit 	6. ☐ Interview S Paper No. 08), 7. ☐ Examiner's 8. ☒ Examiner's	ummary (PTO-413), /Mail Date Amendment/Comment Statement of Reasons for Allowance Kin-Chan Chen	



REASONS FOR ALLOWANCE

1. The following is an examiner's statement of reasons for allowance:

The references of record do not teach or suggest a method comprising: using a microplasma generated at a pressure of not lower than 10,000Pa and not higher than three atmospheric pressures to the surface of the object; removing a natural oxide film, etching a region in which the natural oxide film has been removed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kin-Chan Chen whose telephone number is (571) 272-1461. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you

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have questions on access to the Private PAIR system, contact the Electronic Business

Center (EBC) at 866-217-9197 (toll-free).

Kin-Chan Chen Primary Examiner Art Unit 1765

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